

Notice of References Cited

Application/Control No.

10/817,205

Applicant(s)/Patent Under
Reexamination
CORNWELL ET AL.

Examiner

SHEW-FEN LIN

Art Unit

2166

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Locking in DB2 for MVS/ESA Environment", August 1996, International Technical Support Organization, San Jose Center
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.